



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/881,408  
Filing Date ..... June 13, 2001  
Inventor..... Kie Y. Ahn, et al  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 2814  
Examiner ..... T. Le  
Attorney's Docket No. .... MI22-1534  
Title: A Dielectric Layer Forming Method and Devices Formed Therewith

**PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING AND  
RESPONSE TO DECEMBER 30, 2003 FINAL OFFICE ACTION**

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Assistant Commissioner for Patents  
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**AMENDMENTS**

**Introductory Comments**

The present Response is submitted in the Revised Amendment Format and therefore qualifies for waiver of provisions 37 CFR 1.121(a), (b), (c) and (d).

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